

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re United States Patent Application of:		)	Docket No.:	4240-104
Applicants:	JUNG, Hee Tae, et al.	)	Conf. No.:	9621
		)		
Application No.:	10/805,044	)	Art Unit:	1639
Date Filed:	March 19, 2004	)	Examiner:	Christopher M. Gross
Title:	METHOD FOR FABRICATING A BIOCHIP USING THE HIGH DENSITY CARBON NANOTUBE FILM OR PATTERN	)	Customer No.:	23448
		)		
		)		
		)		
		)		

**CERTIFICATE OF EFS FILING**

I hereby certify that this document is being filed via EFS in the United States Patent and Trademark Office on February 25, 2009.

/kelly k. reynolds/

**RESPONSE TO OCTOBER 28, 2008 OFFICE ACTION AND FEBRUARY 23, 2009  
NOTICE OF NON-COMPLIANT AMENDMENT IN  
U.S. PATENT APPLICATION NO. 10/805,044**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This responds to the October 28, 2008 Final Office Action and the February 23, 2008 Notice of Non-Compliant amendment. The time for responding to the Notice of Non-compliant Amendment was set at one month, or March 23, 2009. This Response is therefore timely and no fees are believed to be due.

DO NOT ENTER:

/Christopher Gross/ (03/19/2009)